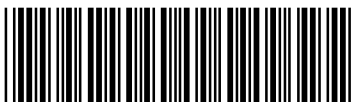


Search Notes (continued)

Application/Control No.

10/559,497

Examiner

JAE LEE

Applicant(s)/Patent under
Reexamination

FUJII, TAKEHIRO

Art Unit

2895

SEARCHED

Class	Subclass	Date	Examiner
438	26	11/6/2009	JML
438	33	11/6/2009	JML
438	113	11/6/2009	JML
438	126	11/6/2009	JML
438	127	11/6/2009	JML

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner
438	26	3/11/2010	JML

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
Full faith and credit from search histories of Morgan Varner	03/11/2010	JML
claim interference search	3/11/2010	JML